

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yasunobu TAGUSA Application No.: Currently unknown Filing or 371(c) Date: Concurrently herewith Title: METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE AND APPARATUS FOR INSPECTING A SEMICONDUCTOR	International Application No.: PCT/JP2005/004036 International Filing Date: March 2, 2005
--	--

GENERAL AUTHORIZATION/REQUEST TO CHARGE PAYMENT OF FEES

Mail Stop PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

With reference to the subject application, and pursuant to 37 C.F.R. § 1.136, Applicant hereby authorizes and requests the Commissioner to treat any correspondence requiring a petition for extension of time as containing such a request therefor for the appropriate length of time. This general authorization is effective during the pendency of this application, including any division or continuing application therefrom.

The Commissioner is authorized to charge payment of any fees or credit any overpayment to Deposit Account No. 50-1353.

Respectfully submitted,

Dated: August 31, 2006

/Christopher A. Bennett #46,710/
Attorneys for Applicants

KEATING & BENNETT, LLP
8180 Greensboro Drive, Suite 850
Tyson's Corner, VA 22102
Telephone: (703) 637-1480
Facsimile: (703) 637-1499

Joseph R. Keating
Registration No. 37,368

Christopher A. Bennett
Registration No. 46,710